



Development of a fluorine-free polymer-assisted-deposition route for $\text{YBa}_2\text{Cu}_3\text{O}_{7-x}$ superconducting films

^aM. Nasui, ^aR.B. Mos, ^aA. Tomolea, ^aT. Petrisor Jr., E. Ware^b,
^aA. Mesaros, ^aM.S. Gabor, ^aL. Ciontea, ^aT. Petrisor

^aTechnical University of Cluj-Napoca, Memorandumului street No. 28, RO-400114 Cluj-Napoca, Romania

^bImperial College London, Exhibition Road, South Kensington, London, SW7 2AZ, United Kingdom

Talk Outline

Goal: Polymer-Assisted Deposition (PAD) of YBCO thin films for coated conductor fabrication

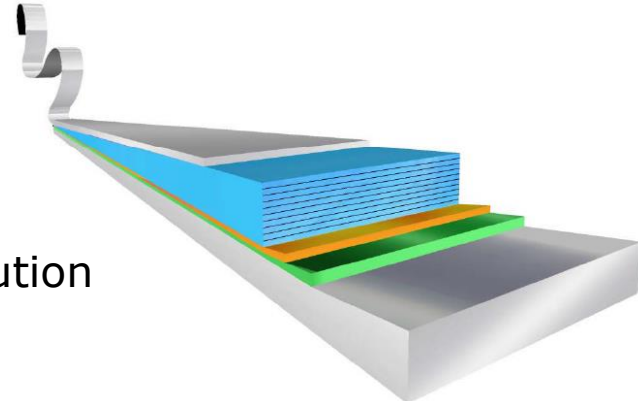
Content

- Advantages of using PAD technique for deposition of YBCO films
- PAD - precursor chemistry
- Precursor characterization
- Phase evolution of YBCO-PAD - Single step thermal treatment
- Influence of pyrolysis temperature on the crystallized films
- Conclusions

Introduction

Coated conductors fabrications by chemical solution deposition

- High performance, low investment and running cost
- Non-vacuum technique
- High production rate and large area
- Molecular scale homogeneity
- Trace elements can easily be introduced into the solution
- **Water sensitive organic salts and flourine solution**



Novelty

Polymer-Assisted Deposition Method, PAD

The idea is to combine solutions of metal precursors with a soluble polymer

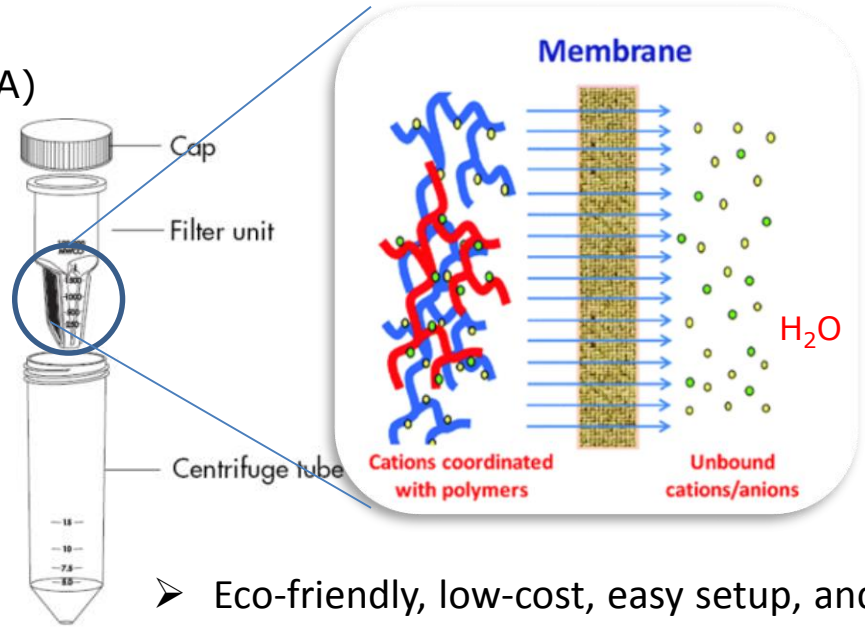
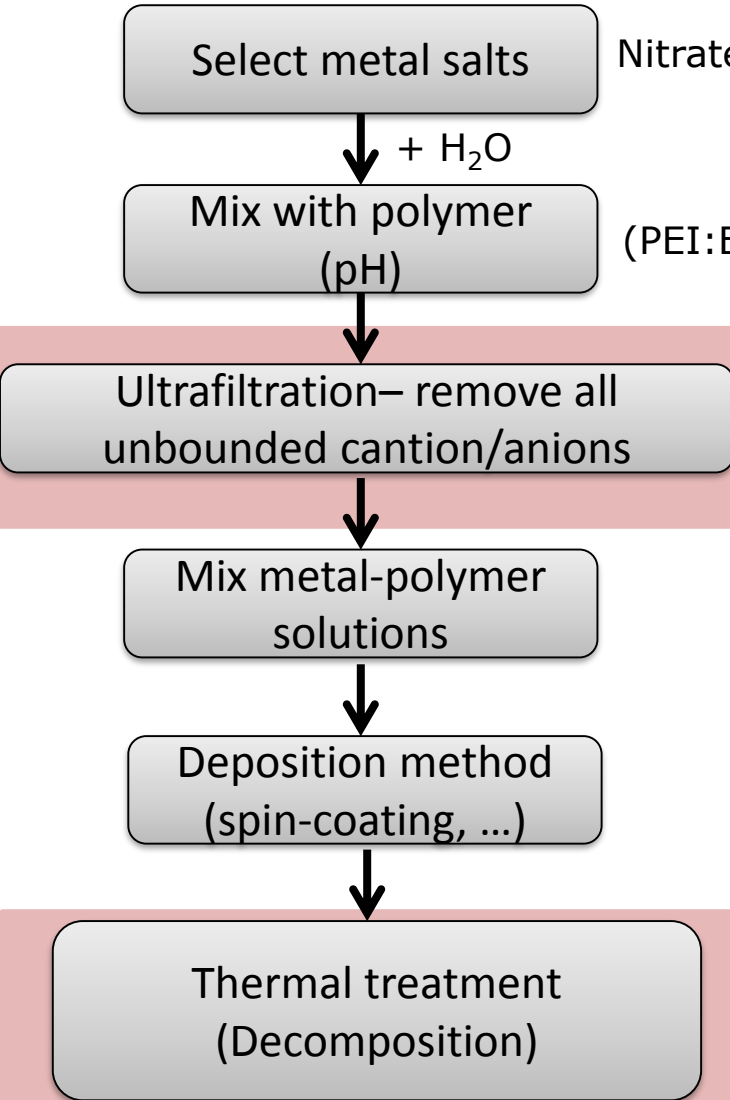
- **ENCAPSULATE** the metal to prevent chemical reaction
- **MAINTAIN HOMOGENEOUS DISTRIBUTION** of the metal in solution

✓ **Eco-friendly process – non fluorine solution (nitrate, acetate, etc.)**

Polymer-Assisted Deposition (PAD) technique

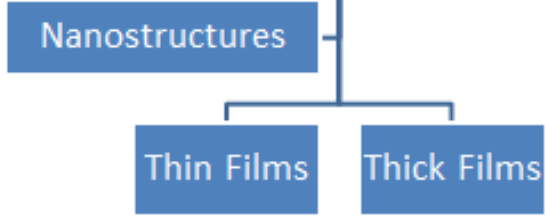
PEI – polyethyleneimine

EDTA – ethylenediaminetetraacetic acid



➤ Eco-friendly, low-cost, easy setup, and ability to coat irregular surfaces

Versatility of the PAD method:



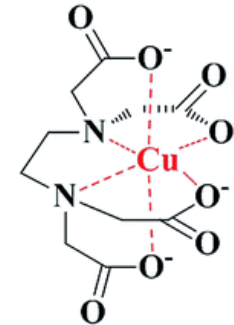
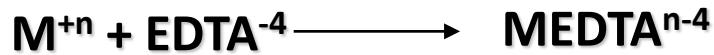
• Long shelf life of the PAD precursor solution (years)

PAD - precursor chemistry

PEI – polyethyleneimine

EDTA – ethylenediaminetetraacetic acid

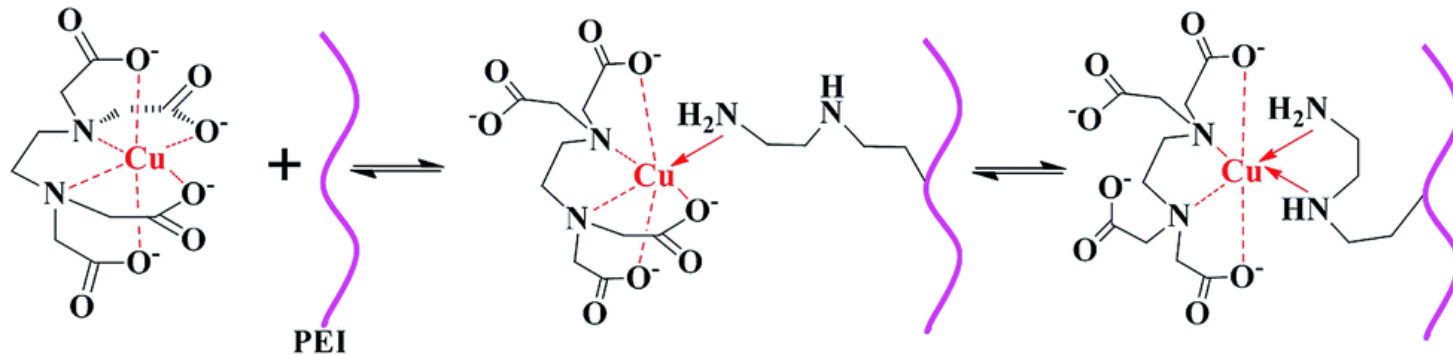
Reaction of $M^{+n}(\text{NO}_3)_3$ with EDTA (M: Y-, Ba-, Cu-)



Single-crystal
under study

Metal-EDTA complex- hexadentate (chelating) ligand

Reaction of $M^{+n}(\text{EDTA})^-$ with PEI



The possible bonding mode of PEI with Cu-EDTA

- EDTA complexes bind to the PEI *via* a combination of **hydrogen bonding** and **electrostatic attraction**;

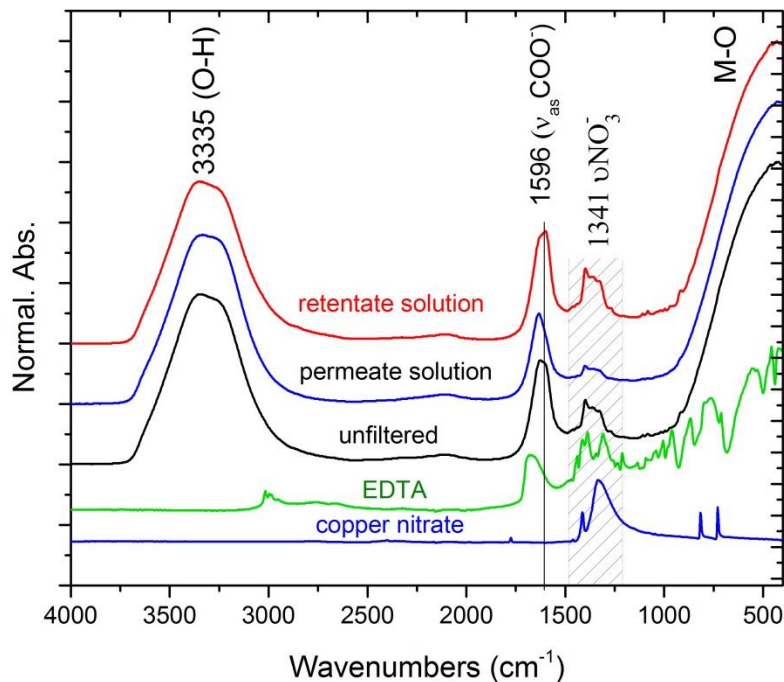
Precursor characterization

Y-, Ba-, Cu-nitrate+H₂O+EDTA+PEI

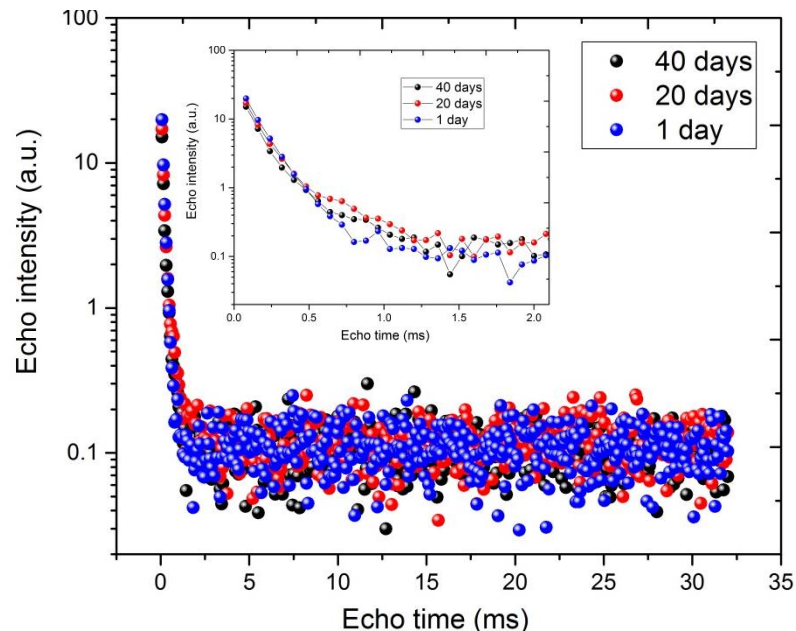
| Solution | Y ³⁺ | Ba ²⁺ | Cu ²⁺ |
|--|-----------------|------------------|------------------|
| Initial solution concentration | 0.28 M | 0.47 M | 1.07 M |
| Final solution concentration (after centrifugation) -ICP | 0.12 M | 0.15 M | 0.36 M |
| pH | 5 | 5 | 5 |
| M ⁺ⁿ :EDTA | 1:1 | 1:1 | 1:1 |
| Efficiency (%) | 59 | 40 | 52.6 |



Cu-precursor - FTIR



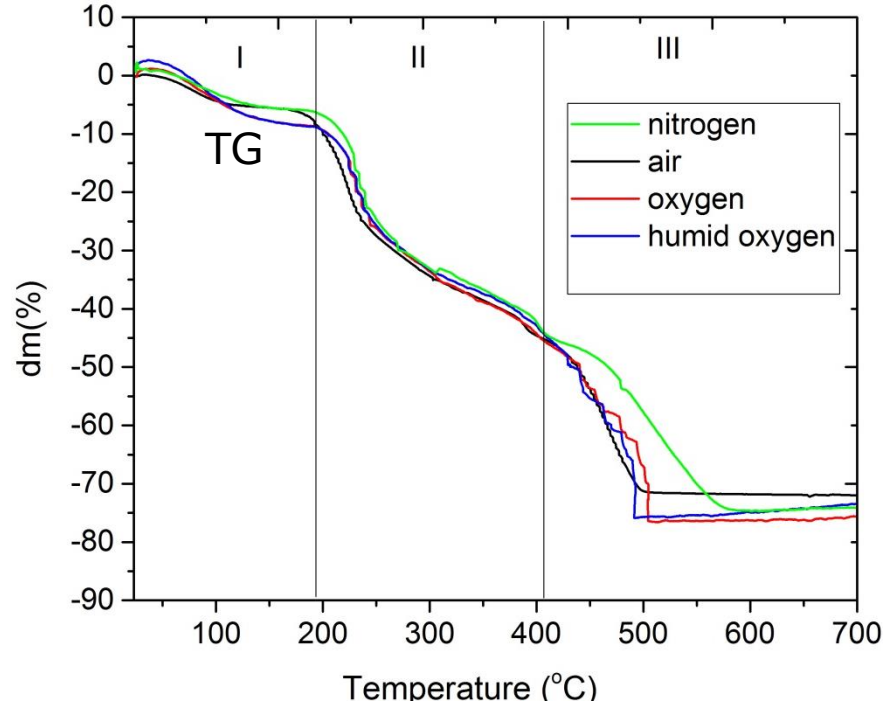
AGING EFFECT- NMR Relaxometry



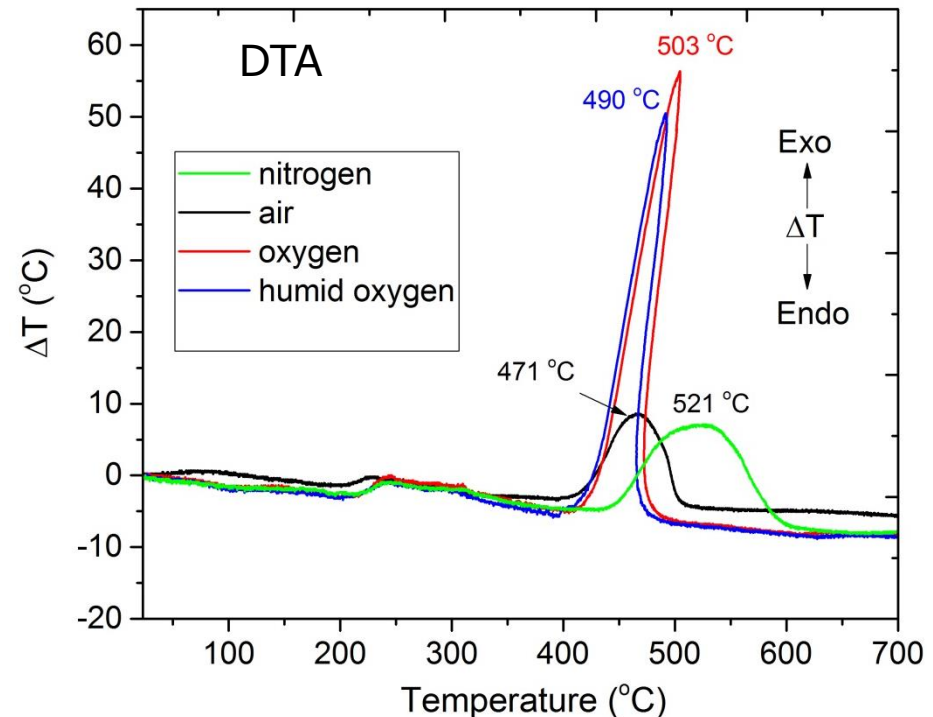
➤ Long stability of the precursor solution

Precursor characterization

Thermal decomposition of the (Y-, Ba-, Cu-) precursor powder

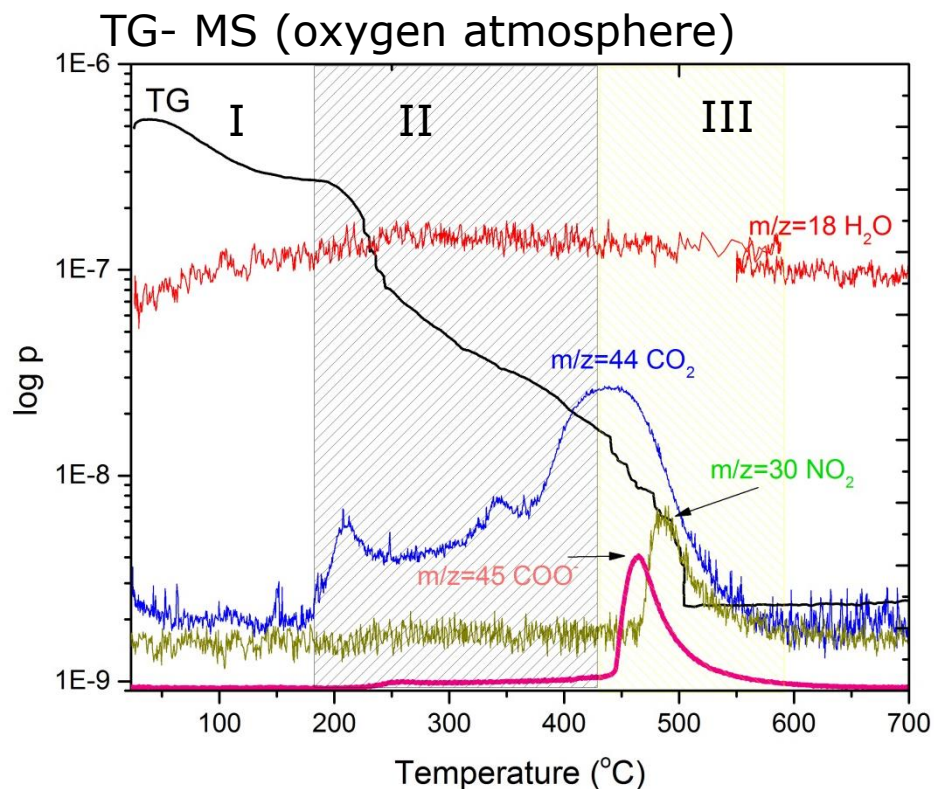


- 23-200 °C - evaporation of water
- 200-400 °C - decomposition of polymer
- 400-550 °C - decomposition of metal complex



- DTA analysis demonstrate that the reaction is exothermic in any of these atmospheres
- Enthalpy of the reaction is higher in O_2

Precursor characterization



Stage

Mass fragment

I - evaporation of solvent

$m/z = 18$ (H_2O)

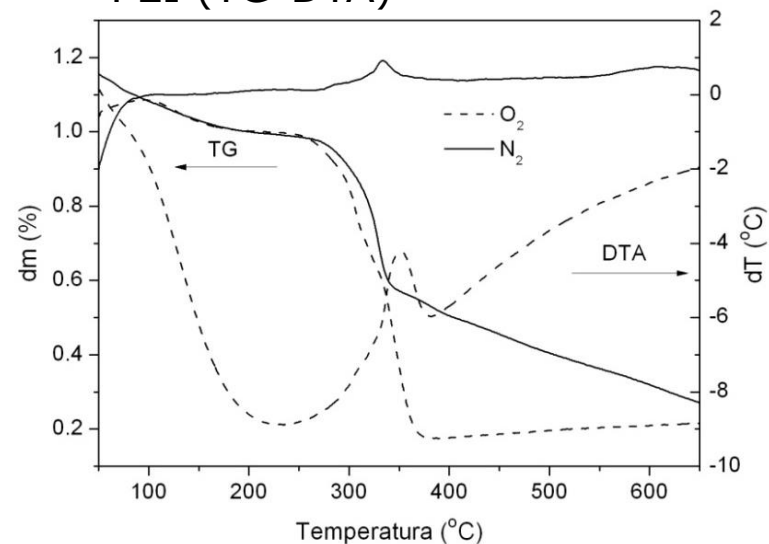
II - decomposition of PEI

$m/z = 18$ (H_2O)
 $m/z = 44$ (CO_2)

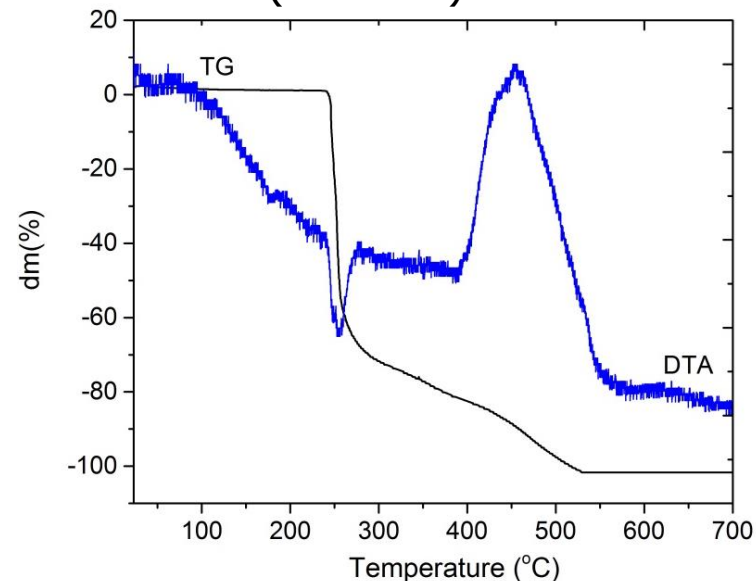
III - decomposition of EDTA complex

$m/z = 44$ (CO_2)
 $m/z = 30$ (NO_2)
 $m/z = 45$ (COO^-)

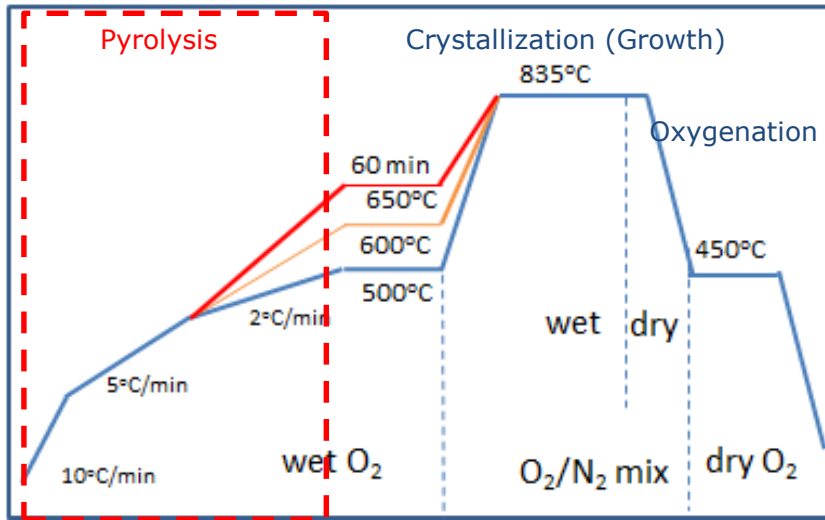
PEI (TG-DTA)



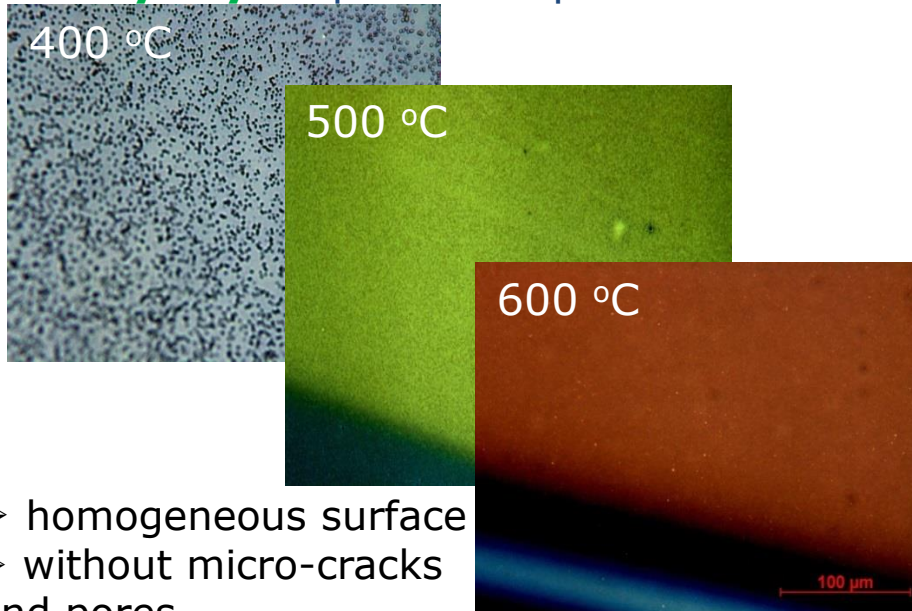
EDTA (TG-DTA)



Single step thermal treatment



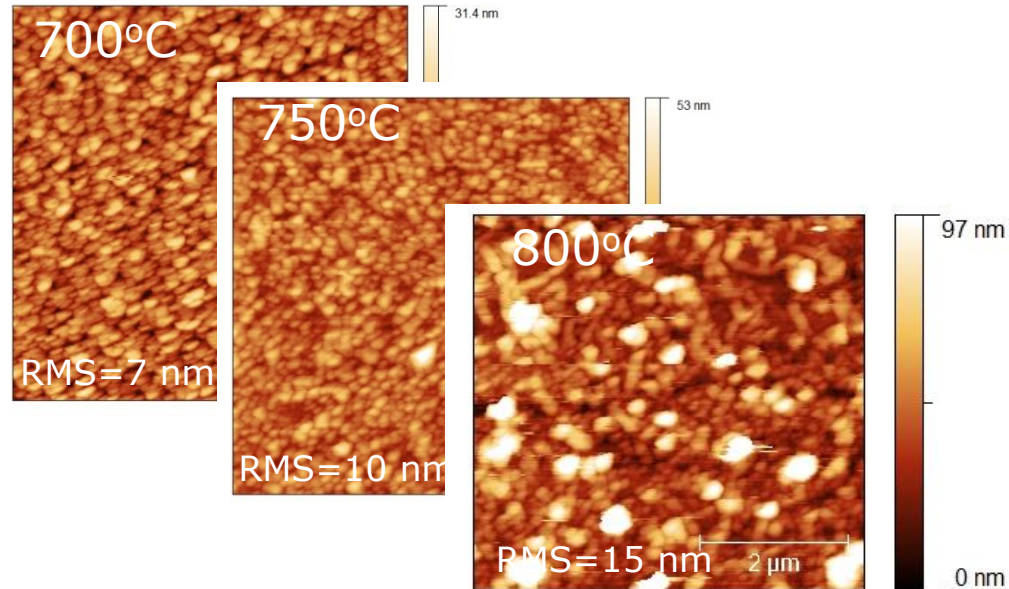
OM **Pyrolysis** process –quenched films



- homogeneous surface
- without micro-cracks and pores

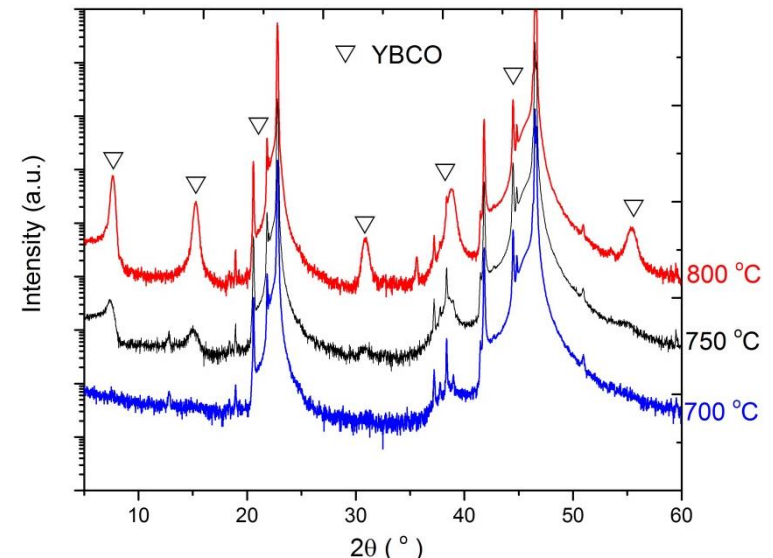
AFM

Crystallization (Growth)



- grains size increase with the increasing crystallization temperature

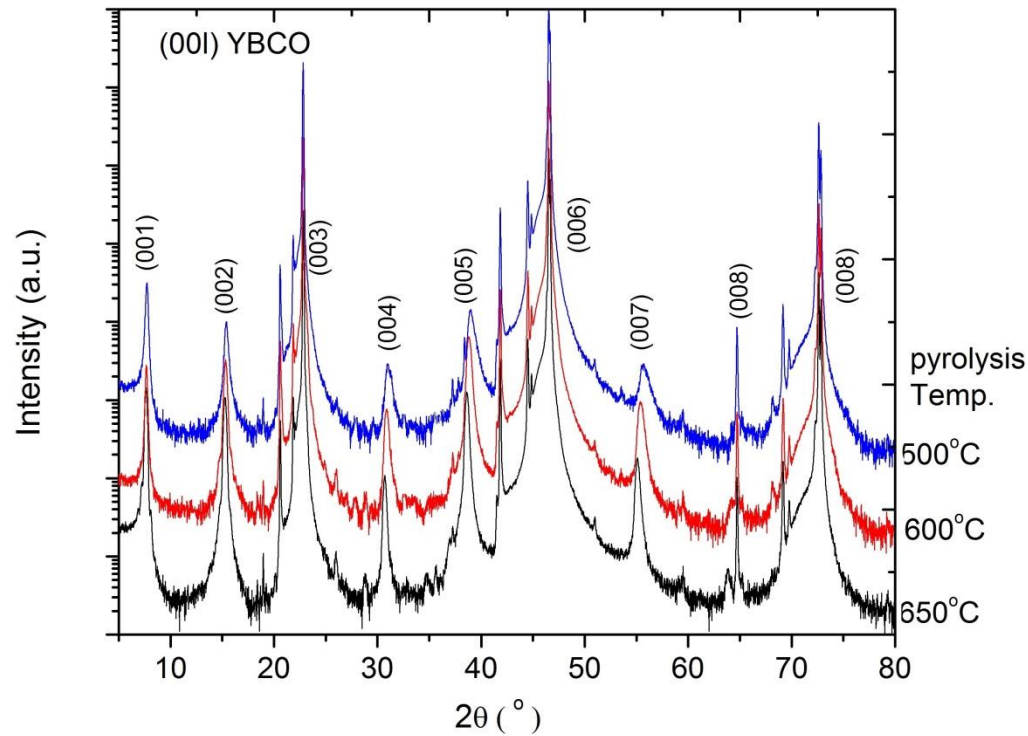
XRD of the quenched films



Structural properties of the YBCO thin films

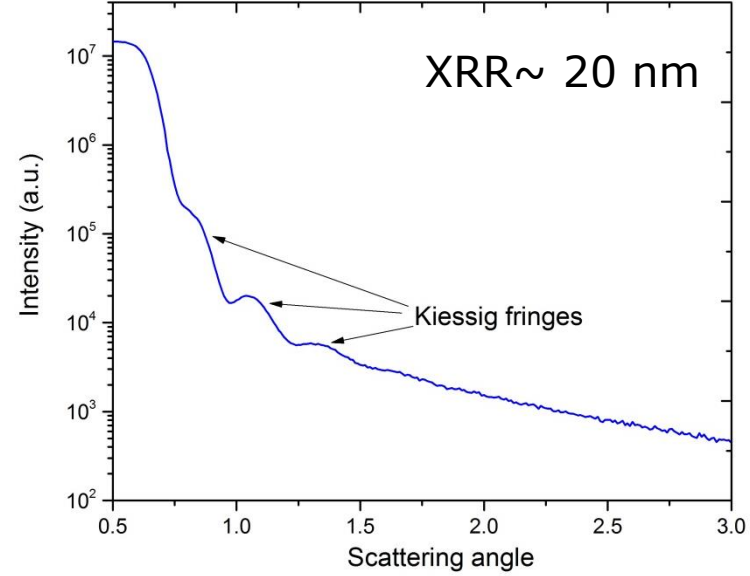
Influence of pyrolysis temperature

XRD- after crystallization 835 °C

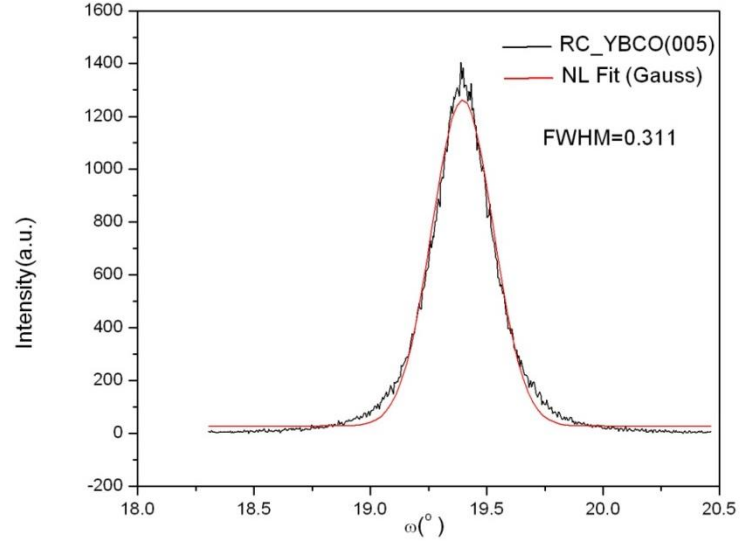


- HR-XRD θ - 2θ scans for the thin films exhibit only (00l) type reflections, indicating that the films are **c - axis oriented**
- No secondary phases

Py- 650°C



Rocking curves around the (005) reflection

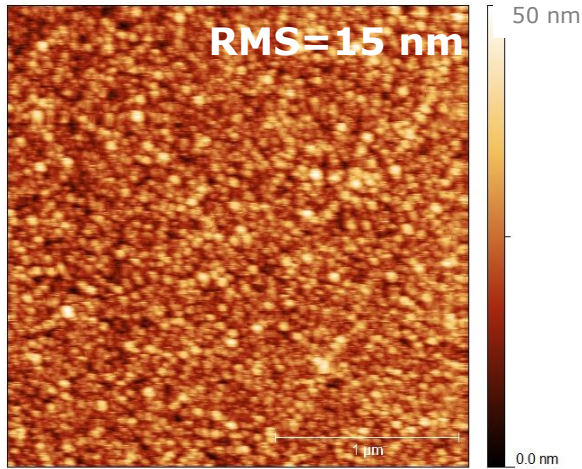


- FWHM = 0.31°, indicates a **low mosaicity**

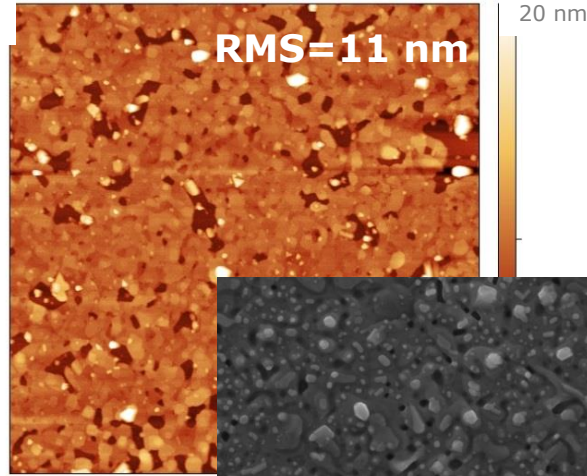
Morphological properties

AFM – after crystallization 835 °C

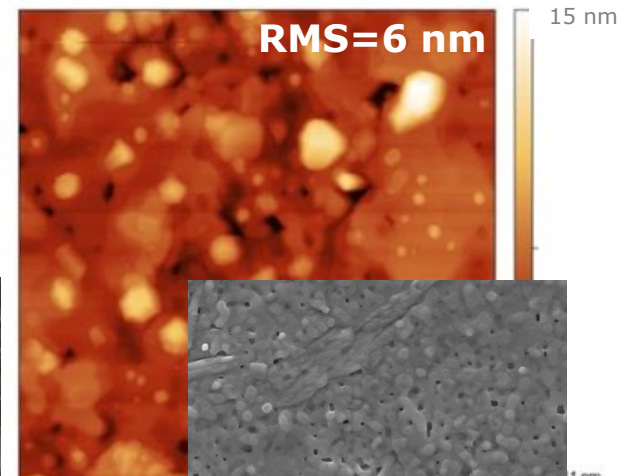
Py-500°C



Py-600°C



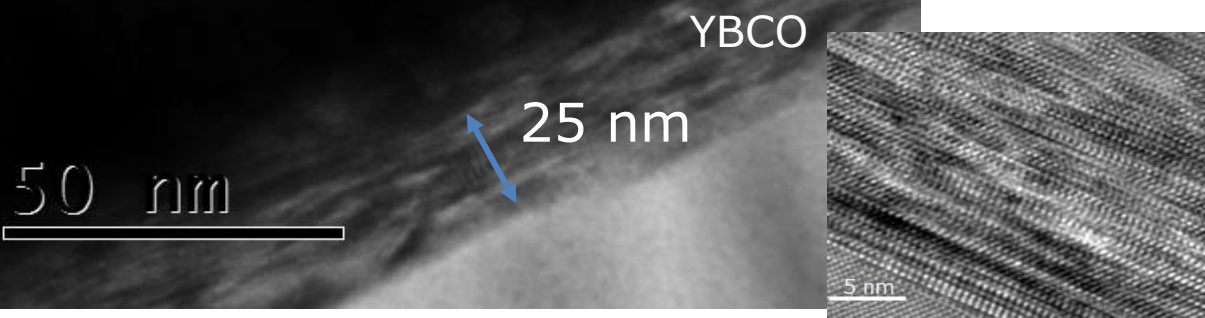
Py-650°C



- homogeneous grain distribution
- the root mean square (rms) roughness value of the YBCO thin films is about 6 nm

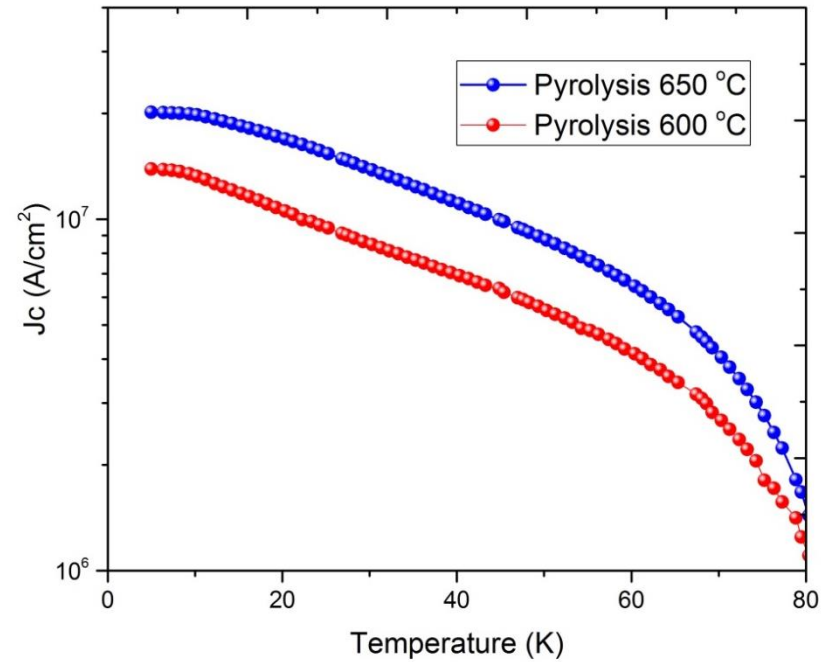
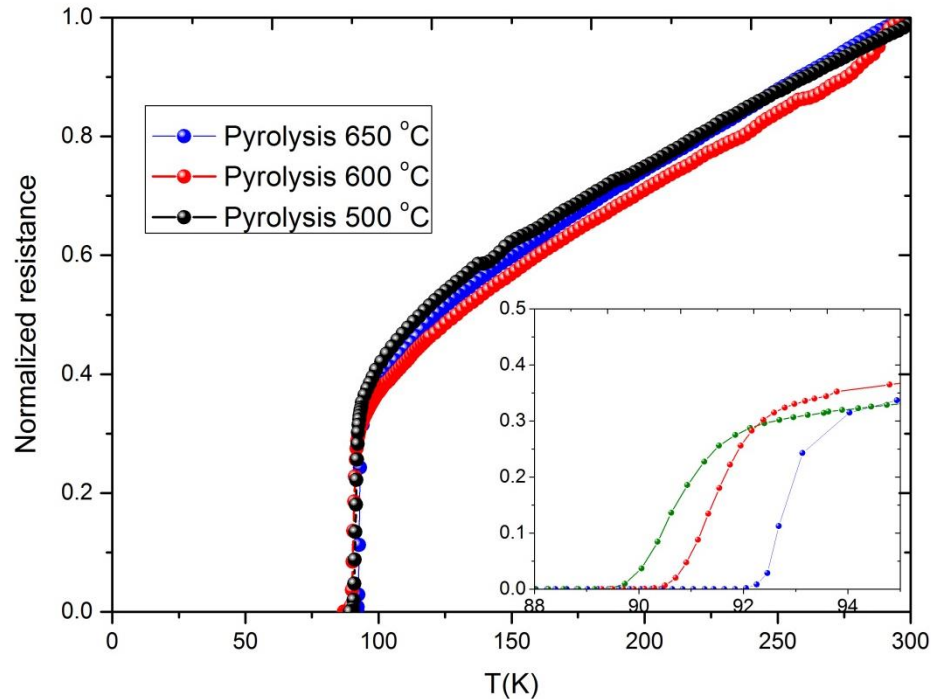
Cross section - TEM

Py-650°C



- coalescence of the film is quite good
- no grains with the a-axis oriented perpendicular to the substrate
- pores are observed

Electrical properties of the YBCO-PAD thin films



Magnetization measurements – J_c values at different temperature

| Pyrolysis temp. | T_c (K) | J_c (MA/cm ²) |
|-----------------|-----------|-----------------------------|
| 500 °C | 88 | 0.45 |
| 600 °C | 90 | 1.5 |
| 650 °C | 91 | 2 |

Conclusions

- It has been demonstrated the possibility of obtaining epitaxial YBCO thin films by Polymer-Assisted-Deposition using nitrates as starting reactants;
- The precursor chemistry were studied by TG, DTA, MS and NMR-relaxometry analyses in order to optimized thermal treatment
- The influence of the pyrolysis temperature (500, 600 and 650 °C) on the final YBCO films was studied
- Crystalline and epitaxially oriented YBCO layers (20 nm) with smooth surfaces and small surface roughness of about 6-10 nm were obtained on (100)LAO single-crystalline substrates;
- The electrical characterization have indicated that the YBCO thin films have the $T_c=90$ K ($R=0$), J_c (77K)= $0.45 \cdot 10^6$ MA/cm²

Future work

- Variation of the pH values in order to increase the efficiency after ultrafiltration
- Increasing the thickness of the YBCO-PAD films (conc., multiple deposition)
- Test over metallic tapes

Acknowledgments



Grant CNCS – UEFISCDI, Project number PN II-RU-TE-2014-4-2848, MAGPIN.



Thank you for your attention